

Appln No.: 10/064,500 Page 1 of 3 Applicant(s): Martin B. Barmatz et al. MICROWAVE BONDING OF THIN FILM METAL COATED SUBSTRATES

1/3

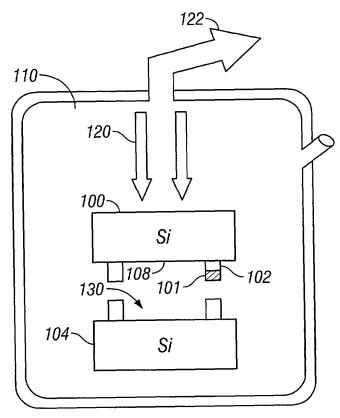
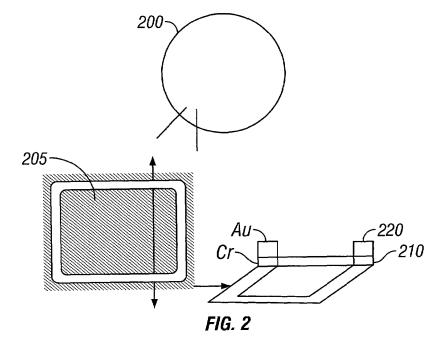


FIG. 1





Appln No.: 10/064,500 Page 2
Applicant(s): Martin B. Barmatz et al.
MICROWAVE BONDING OF THIN FILM METAL COATED

**SUBSTRATES** 

*2/3* 

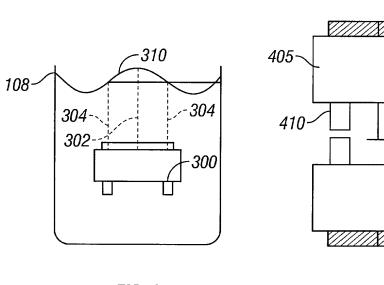
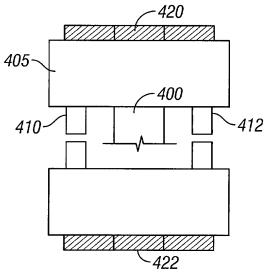


FIG. 3



Page 2 of 3

FIG. 4

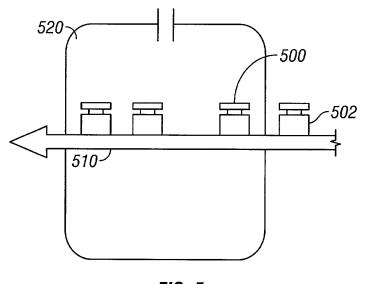


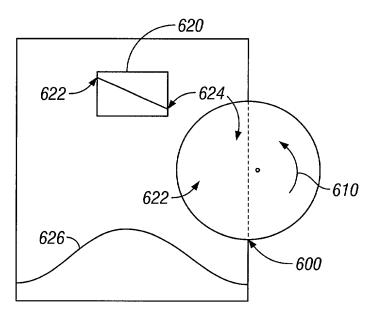
FIG. 5



Appln No.: 10/064,500 Page 3
Applicant(s): Martin B. Barmatz et al.
MICROWAVE BONDING OF THIN FILM METAL COATED

SUBSTRATES

3/3



Page 3 of 3

FIG. 6

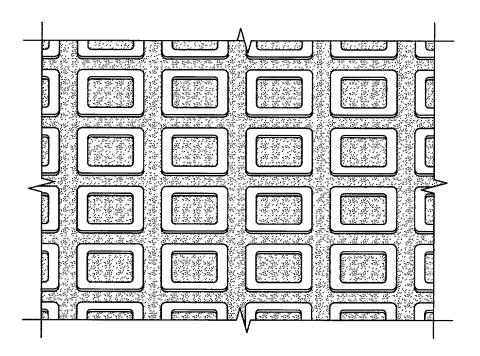


FIG. 7